

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Taku KANAOKA et al.

Appln. No.:

Filed: HERewith

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING  
THE SAME

\* \* \*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any  
assertion as to materiality or prior art effect, the  
document listed on the attached Form PTO-1449 is hereby  
cited.

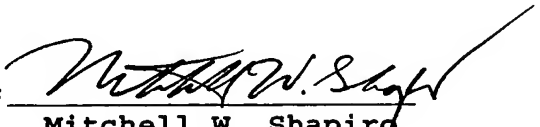
The document on the attached List was cited in the  
specification, on page 2, and its relevance is indicated  
therein.

Respectfully submitted,

MWS:lat

Miles & Stockbridge P.C.  
1751 Pinnacle Drive  
Suite 500  
McL an, Virginia 22102-3833  
(703) 903-9000

By:

  
Mitchell W. Shapiro  
Reg. No. 31,568

August 5, 2003

<b>FORM PTO-1449</b>				<b>Atty. Docket No.</b> <b>XA-9913</b>		<b>Appln. No.</b>	
<b><u>LIST OF DOCUMENTS CITED BY APPLICANT</u></b>							
				<b>Applicant</b> <b>Taku KANAOKA et al.</b>			
				<b>Filing Date</b> <b>HEREWITH</b>		<b>Group</b>	
<b>U.S. PATENT DOCUMENTS</b>							
<b>Examiner Initial</b>		<b>Document Number</b>	<b>Date</b>	<b>Name</b>	<b>Class</b>	<b>Sub-class</b>	<b>Filing Date</b>
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
<b>FOREIGN PATENT DOCUMENTS</b>							
<b>Examiner Initial</b>		<b>Document Number</b>	<b>Date</b>	<b>Country</b>	<b>Class</b>	<b>Sub-class</b>	<b>Translation</b>
	AJ	3022565	1/14/00	Japan			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						
<b>OTHER (including author, title, date, pertinent pages, etc.)</b>							
	AP						
	AQ						
	AR						
<b>Examiner</b>				<b>Date Considered</b>			
<b>XAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							